

19 mW. To enhance the power of this laser source, a cavity, singly resonant for 1344 nm, is used. The cavity length is stabilized to the diode laser's frequency using the Pound-Drever-Hall method. With a finesse of 200, an enhancement factor of up to 60 was achieved, leading to a circulating power of 0.9 W at 1344 nm.

The MgO:PPLN crystal (HCP Photonics) is 7.4 mm long, 0.5 mm thick, 10 mm wide, and possesses six different poling periods in the range of 21–25.4 μm . Crystal faces are polished plane-parallel and antireflection (AR)-coated. The crystal's temperature is adjustable between 20–100°C, using a Peltier element driven oven. The attenuation coefficient α of the MgO:PPLN was independently measured to be $\alpha = 6.75 \text{ cm}^{-1}$ at 5.485 μm and is a significant limiting factor on the achievable output power in the spectral range around 5 μm . Pump and signal beams are focused by lenses L1 (fiber collimator) and L2 (175 mm focal length) into the $\Lambda = 25.4 \mu\text{m}$ poling period section of the crystal. In order to minimize the absorption of the generated 5 μm radiation, the foci of the two lasers, and therefore the region of largest DFG power generation, are close to the exit face of the crystal. The working point for best phase matching is 71°C, resulting in a DFG output power up to 105 μW at 5.115 μm . The mid-IR output is collimated and focused using an AR-coated CaF_2 lens (L3). The pump and signal beams are separated from the idler beam using a CaF_2 prism (P), which efficiently transmits the *p*-polarized idler wave. For detection, the 1064 nm wave is chopped and the modulated 5.1 μm wave is sent on a pyroelectric detector (PYRO-LME 353) followed by lock-in detection.

In addition, the poling period $\Lambda = 24.2 \mu\text{m}$ was tested for DFG with the diode laser tuned to 1320 nm, and both lasers in single-pass configuration (no cavity), obtaining tunable radiation in the range of 5.42–5.48 μm with 0.1 μW output level.

The frequency of the 1344 nm diode laser is stabilized to and measured by a frequency comb that is also used for frequency measurement of the iodine-stabilized 1064 nm Nd:YAG laser. The frequency comb is based on a Ti:Sapphire laser and a Menlo Systems comb kit (FC 8004), modified in-house. The 1344 and 1064 nm waves are sent via two 70 m fibers to the frequency comb lab. Here, after coupling the waves out of the fibers, they are sent into two beat lines, in which the cw waves are overlapped with the comb radiation and their beats detected by fast photodetectors. Appropriate bandpass filters block the unnecessary comb modes before the overlap. The beat between the laser waves and the nearest comb modes are filtered and amplified with tracking oscillators. The frequency comb's repetition rate f_{rep} and carrier envelope frequency f_{CEO} are locked to a hydrogen maser controlled synthesizer, and the maser is itself steered to GPS on long time scales. Figure 2 shows the beat note of the 1344 nm diode laser which is frequency-stabilized to a fixed radio frequency (r.f.) with the aid of a frequency-phase detector [12]. The linewidth of the beat note is $\Gamma_{1344\text{-comb}} \approx 720 \text{ kHz}$. The linewidth of the iodine-stabilized Nd:YAG laser is $\Gamma_{1064} \approx 150 \text{ kHz}$, determined by beating with an independent narrow-linewidth Nd:YAG laser. The linewidth of the frequency comb modes is $\Gamma_{\text{comb}} \approx 272 \text{ kHz}$, also determined from

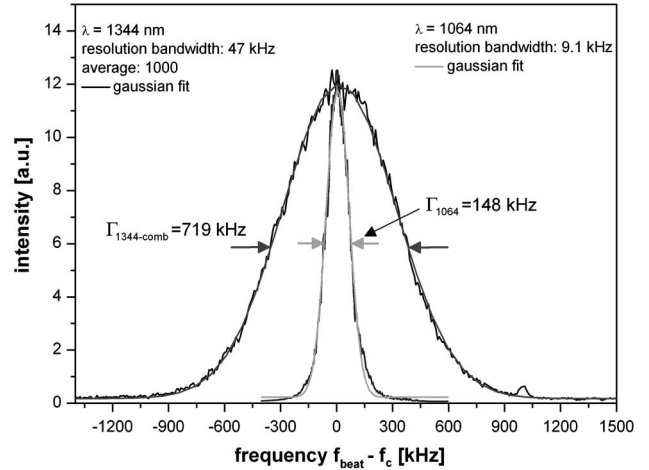


Fig. 2. Beat notes between the 1344 nm diode laser and the frequency comb and between the 1064 nm Nd:YAG laser and a narrow-linewidth (10 kHz) Nd:YAG laser (ILF100, Institute for Laser Physics, Novosibirsk).

a beat with the independent Nd:YAG laser. Therefore, the linewidth of the 5.1 μm radiation is approximately

$$\Gamma_f = (\Gamma_{1064}^2 + \Gamma_{1344\text{-comb}}^2 - \Gamma_{\text{comb}}^2)^{1/2} \approx 0.68 \text{ MHz}.$$

The beat notes are counted by a dead-time-free frequency counter and logged together with the frequency comb's repetition rate f_{rep} and the calculated DFG frequency. Figure 3 shows the time traces of the Nd:YAG and the diode laser frequencies, measured with the frequency comb and the calculated difference frequency at 5.1 μm . Its frequency instability is mostly due to that of the Nd:YAG laser, because of limitations of the iodine stabilization. The Allan deviation is shown in Fig. 4. The frequency instability is less than 25 kHz for short integration times and drops to 4 kHz for an integration time above 200 s.

Tuning of the generated difference frequency at 5.1 μm can be done by variation of the frequency comb's repetition rate f_{rep} , while all systems remain in lock. Typically,

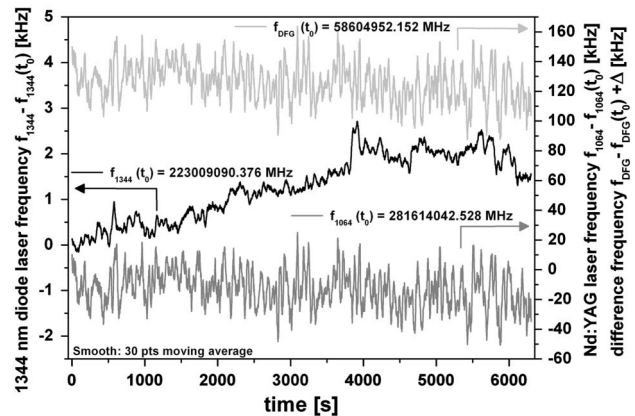


Fig. 3. Frequency traces of the Nd:YAG laser and of the diode laser, measured by the frequency comb over more than 1 h and the corresponding frequency trace of the generated difference frequency at 5.1 μm . The DFG frequency trace has a frequency offset of $\Delta = +140 \text{ kHz}$ for illustration purpose. Note the different vertical scales.

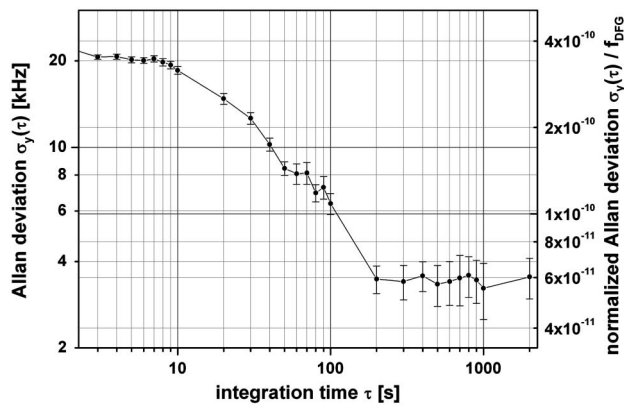


Fig. 4. Allan deviation of the difference frequency values at $5.1 \mu\text{m}$.

a frequency sweep of (only) 10 MHz/min, depending on the comb's working point, could be achieved.

A second approach for tuning the QD-ECDL's frequency while in lock, and thus the frequency of the $5.1 \mu\text{m}$ radiation, has been implemented using a waveguide intensity modulator (Photline Technologies, MX1300-LN-10). The LiNbO_3 -based, low-insertion-loss intensity modulator is driven by a signal generator at a r.f. f_s and generates two symmetric sidebands ($f_{1344} \pm f_s$) with respect to the carrier frequency f_{1344} , which is kept fixed (stabilized to the comb). For sufficiently high r.f. drive strength, the carrier is suppressed and its power (nearly) completely transferred to the sidebands. The enhancement cavity is locked onto one sideband, e.g., $f_{1344} - f_s$, via the Pound-Drever-Hall technique. The generated $5.1 \mu\text{m}$ radiation $f_{1064} - (f_{1344} - f_s)$ then has a frequency offset $+f_s$ with respect to the frequency $f_{1064} - f_{1344}$ measured by the comb. The r.f. f_s can be swept in time and the cavity lock system follows the sweep, yielding a frequency sweep in the generated $5.1 \mu\text{m}$ radiation. Figure 5 shows a typical frequency sweep. The maximum sweep range for f_s is 15 to 475 MHz, with an output power of about $2.2 \mu\text{W}$ at $5.1 \mu\text{m}$. It is possible to manually change to a lock on the opposite sideband, thereby doubling the sweep range. To determine whether the cavity is locked to the positive or negative sideband (and therefore knowing the actual frequency at $5.1 \mu\text{m}$), the voltage applied to the cavity mirror piezo actuator is constantly monitored. When the lock is to the negative sideband " $-f_s$ ", the corresponding piezo voltage decreases upon increasing the modulation frequency, while the opposite is the case for a lock to the positive sideband " $+f_s$ ". The maximum frequency tuning rate was 35 MHz/s.

This $5.1 \mu\text{m}$ source was successfully used in an experiment that observed and measured the frequency of the most fundamental electric dipole-allowed molecular vibrational transition, the $v = 0 \rightarrow v = 1$ transition in the molecule HD^+ (observed linewidth: 3 MHz) [13].

In conclusion, we have developed a cw narrowband mid-IR source with $105 \mu\text{W}$ maximum output power based on DFG between a Nd:YAG laser and a $1.3 \mu\text{m}$ QD-ECDL. The source was tunable to any frequency in the $5.09\text{--}5.13 \mu\text{m}$ range and is relatively rapidly tunable over a range of 460 MHz, using a sideband generator, with an output power of $2.2 \mu\text{W}$. Stabilized in part and measured

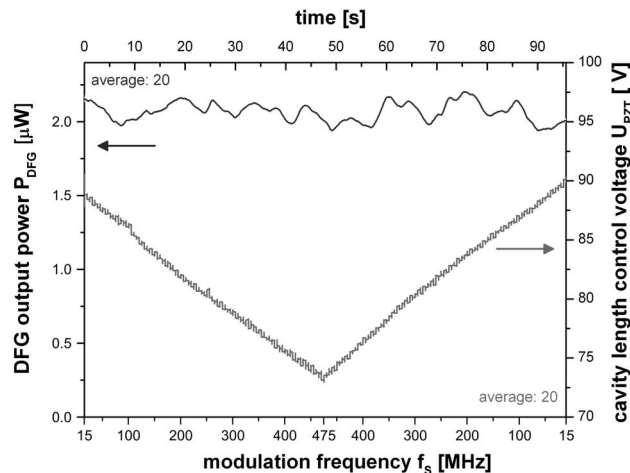


Fig. 5. DFG output power and the cavity length control voltage during a typical frequency sweep using the intensity modulator tuned to the negative sideband " $-f_s$ ".

by a hydrogen-maser/GPS-referenced Ti:sapphire frequency comb, the generated $5.1 \mu\text{m}$ radiation possessed a frequency instability of 8 kHz or less for integration times larger than 10 min and a spectral linewidth smaller than 700 kHz, making it well suitable for precision spectroscopic applications.

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